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Amdt
9/A

684.2985

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HITOSHI NAKANO

Application No.: 09/536,637

Filed: March 28, 2000

For: APPARATUS WITH AIR-
CONDITIONING SYSTEM, AND
DEVICE MANUFACTURING
METHOD USING THE SAME

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Examiner: L. Ciric
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Group Art Unit: 3743
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October 9, 2001
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Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

RECEIVED
OCT 12 2001
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Sir:

In response to the Office Action dated July 9, 2001, the Examiner is respectfully requested to amend the above-identified application as follows:

IN THE SPECIFICATION:

Please substitute the following paragraph for the paragraph starting at page 1, line 5 and ending at line 13. A marked-up copy of this paragraph, showing the changes made thereto is attached.

-This invention relates to an apparatus having an air-conditioning chamber

A- wherein high temperature stability is required and, more particularly, to an apparatus having an